



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

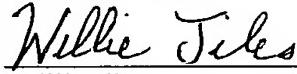
In re Application of: Seung Ki Joo et al.
Serial No.: 10/038,990
Filing Date: January 4, 2002
Examiner: Thao X. Le
Confirmation No. 9637
Group Art Unit: 2814
Title: *Method of Fabricating a Semiconductor Device Including a Crystalline Active Silicon Layer*

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
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Willie Jiles

RESPONSE PURSUANT TO 37 C.F.R. § 1.111

Applicants hereby respond to the Office Action dated December 2, 2003.